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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE



Re Application of:  
Gaillard, et al.

Serial No.: 10/789,209

Confirmation No.: 9101

Filed: February 27, 2004

For: Method of Decreasing the  
K Value in SIOC Layer  
Deposited by Chemical  
Vapor Deposition

Group Art Unit: 2818

Examiner: David Nhu

*Entry  
Signature  
6/3/05*  
MAIL STOP ISSUE FEE  
Commissioner for Patents  
P.O. Box 1450  
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Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>6/3/05</u> , 2005 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Issue Fee, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.	
<u>6/3/05</u>	<u>Kin Z. Zhu</u>
Date	Signature

## AMENDMENT AFTER ALLOWANCE

Following mailing of a Notice of Allowance on May 9, 2005, Applicants request entry of the following amendments. **Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **Remarks** begin on page 6 of this paper.